

41

AUG 25 2003

In re Application of:

MASAYAKA ITO

Application No.: 10/091,461

Filed: March 7, 2002

For: SOI SUBSTRATE, ANNEALING  
METHOD THEREFOR, SEMICONDUCTOR  
DEVICE HAVING THE SOI SUBSTRATE,  
AND METHOD OF MANUFACTURING  
THE SAME

Docket No. 00862.022541.

Examiner: S. Isaac

Group Art Unit: 2812

2812  
RECEIVED  
SEP 4 2003  
TECHNOLOGY CENTER 2800

Date: August 22, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an amendment in the above-identified application.

 No additional fee is required.

The fee has been calculated as shown below

| CLAIMS AS AMENDED                              |  |       |  |                         |                |                   |
|--|--|-------|--|-------------------------|----------------|-------------------|
|  | (2)<br>CLAIMS<br>REMAINING<br>AFTER<br>AMENDMENT |       | (4)<br>HIGHEST NO.<br>PREVIOUSLY<br>PAID FOR | (5)<br>PRESENT<br>EXTRA | RATE           | ADDITIONAL<br>FEE |
| TOTAL<br>CLAIMS                                | 16   | MINUS | 20   | = 0                     | x \$9<br>\$18  | .00               |
| INDEP.<br>CLAIMS                               | 2  | MINUS | 3  | = 0                     | x \$42<br>\$84 | .00               |
| Fee for Multiple Dependent claims \$140°/\$280 |  |       |  |                         |                |                   |
| TOTAL ADDITIONAL FEE<br>FOR THIS AMENDMENT---  |  |       |  |                         |                | .00               |

 °Verified Statement claiming small entity status is enclosed, if not filed previously. A check in the amount of \$\_\_\_\_ is enclosed.

Charge \$\_\_\_\_ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.

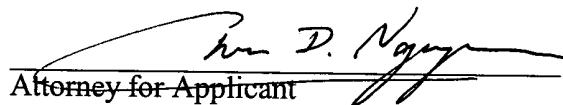
Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.

A check in the amount of \$\_\_\_\_ to cover the fee for a \_\_\_\_ month extension is enclosed.

A check in the amount of \$\_\_\_\_ to cover the Information Disclosure Statement fee is enclosed.

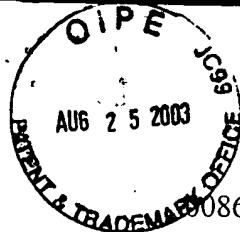
Applicant's undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
\_\_\_\_\_  
Attorney for Applicant  
Registration No. 54, 536

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3801  
Facsimile: (212) 218-2200

CA\_MAIN 68648 v 1



0862.022541.

PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

MASATAKA ITO

Application No.: 10/091,461

Filed: March 7, 2002

For: SOI SUBSTRATE, ANNEALING  
METHOD THEREFOR,  
SEMICONDUCTOR DEVICE  
HAVING THE SOI SUBSTRATE,  
AND METHOD OF  
MANUFACTURING THE SAME

Examiner: S. Isaac

Group Art Unit: 2812

August 22, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450AMENDMENT

Sir:

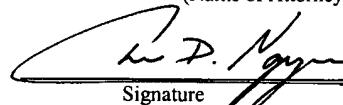
In response to the Office Action dated May 22, 2003 (Paper No. 9), please amend the above-identified application as follows:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

---

August 22, 2003  
(Date of Deposit)

---

Chris D. Nguyen (Reg. No.54,336)  
(Name of Attorney for Applicant)

---

August 22, 2003  
Signature Date of Signature